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Dated: March 5, 2007

Signature: 

(Arnold H. Krumholz)

Docket No.: AWA 3.3-006
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Jager et al.

Application No.: 10/553,447

Group Art Unit: 1775

Filing Date: October 26, 2006

Examiner: Not Yet
Assigned

For: METHOD FOR PRODUCING A
MICROMACHINED LAYERED DEVICE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

It is respectfully requested that the references listed on the enclosed Form PTO-1449 be made of record and considered with respect to the above-referenced U.S. patent application. A copy of each reference is enclosed. These references were cited in the background section of the present specification. Submission of the present Information Disclosure Statement should not be taken as an admission that the cited references are legally available prior art or that the same are pertinent or material.

In the event that any fee is due in connection with the present Information Disclosure Statement, the Commissioner is hereby authorized to charge the same to our Deposit Account No. 12-1095.

Dated: March 5, 2007

Respectfully submitted,

By 

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Substitute for form 1449/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	10/553,447-Conf. #1478
				Filing Date	October 26, 2006
				First Named Inventor	Edwin Jager
				Art Unit	1775
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	AWA 3.3-006

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶

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NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	CA	KOVAS et al., "Silicon Micromachining: Sensors to Systems", Analytical Chemistry, Vol. 68, pgs. 407A-412A, July 1, 1996		
	CB	SMELA, "Microfabrication of PPy microactuators and other conjugated polymer devices", J. Micromech. Microeng., Vol. 9, No. 1, pgs. 1-18, 1999, IOP Publishing Ltd.		

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